

Integration strategies and nanoscale electrical characterization of MoS₂ on wide bandgap semiconductors

Salvatore Ethan PANASCI¹, Emanuela Schilirò¹, Antal Koos², Simonpietro Agnello³, Béla Pécz²,
Fabrizio Roccaforte¹, Filippo Giannazzo¹

¹ Consiglio Nazionale delle Ricerche, CNR-IMM, Catania, Italy

² HUN-REN, Centre for Energy Research, Institute of Technical Physics and Materials Science,
Budapest, Hungary

³ Department of Physics and Chemistry Emilio Segré, University of Palermo, Palermo, Italy

Molybdenum Disulfide (MoS₂) belongs to the family of transition metal dichalcogenides (TMDs), which are layered materials formed by stacks of X-M-X trilayers (being M=Mo,W transition metals and X=S, Se, Te chalcogens) with covalent in-plane bonds and weak van der Waals interaction between the layers. The semiconducting properties with a thickness dependent energy bandgap (1.2 eV indirect bandgap from multilayers to 1.8-1.9 eV direct gap for a single layer) [1], combined with a high electron mobility (200-400 cm²/Vs) [2], make MoS₂ suitable for a wide number of potential applications in electronics, optoelectronics and sensing. In this context, many efforts are currently in progress to integrate large-area 1L MoS₂ films on SiC and GaN substrates, with the aim to develop 2D/3D heterojunction diodes and photodetectors taking benefit of the combination of WBG semiconductors and MoS₂ properties.

This talk will present an overview of the state of the art integration strategies for MoS₂ on WBG semiconductors, with a special focus on a two-step growth method, consisting in the sulfurization of pre-deposited ultra-thin MoO_x films, which proved very effective to achieve uniform 1L MoS₂ coverage on large areas by controlling the initial film thickness [3-4]. The structural, chemical, vibrational/optical and electrical properties of the obtained MoS₂/WBG heterostructures have been extensively investigated by the combination of several characterization techniques (AFM, XPS, TEM, Raman, Photoluminescence, C-AFM and KPFM). In particular the relevant electronic properties of these systems, such as the energy band alignments at the heterointerfaces, have been evaluated, paving the way to new device applications.

This work has been supported by the FlagERA-JTC 2019 project ETMOS, the MUR-PNRR projects iENTRANCE@ENL (No. IR00000027) and the PRIN project "2DIntegratE" (2022RHRZN2).

References:

- [1] A. Splendiani et al. *Nano letters* 10(4), 1271-1275 (2010).
- [2] B. Radisavljevic, et al. *Nature nanotechnology* 6(3), 147-150 (2011).
- [3] S.E. Panasci et al. *Nanomaterials* 12, 182 (2022).
- [4] F. Giannazzo et al. *Advanced Materials Interfaces* 9, 2200915 (2022).
- [5] F. Giannazzo et al. *Applied Surface Science* 631, 157513 (2023).